



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of.:

Yair EIN-ELI et al

Serial No.:

10/750,969

Filed:

January 5, 2004

For:

TEXTURING A

SEMICONDUCTOR MATERIAL **USING NEGATIVE POTENTIAL**

DISSOLUTION (NPD)

Attorney Docket:

Group Art Unit:

27054

1742

Examiner:

Nicholas A. Smith

Mail Stop: Amendment Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

ELECTION

Sir:

Further to the Election filed March 1, 2007, Applicants elect species 4, a method of texturing an unmasked unpolished semiconductor material.

Claims 17, 20 and 69 are directly readable on the elected species.

All the elected claims are readable on the elected species except for claims 18, 19 and 70.

An examination of claims 1-17, 20-69 and 71-92 is respectfully requested.

Respectfully submitted,

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Date: March 13, 2007